**Anne-Claire SALAÜN**

**Biography**

Anne-Claire Salaün received her PhD degree in physics from the University of Rennes (France) in 1996 and her research director graduation in electronics from the University of Rennes (France) in 2010. She is associate professor in the “Departement Microelectronique et Microscapteurs” (DMM) in the Institut d’Electronique et de Telecommunications de Rennes (IETR), France. Since 2015, she is head manager of the Electrical Engineering and Industrial Computing (EEIC) department of the Institut Universitaire de Technologie (IUT) of Rennes. Her research activities are devoted to the low temperature (<600°C) polysilicon or silicon nanowires TFT fabrication and micro-technology, with applications to chemical and biological sensors. She focuses on sensors based on silicon nanowire. She supervised 8 phD students and she is author or co-author of over 30 international journal papers or 70 conference proceedings.